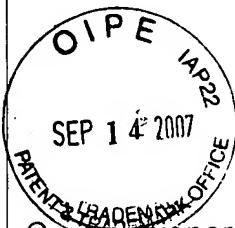


JENKINS
WILSON
TAYLOR
& HUNT

patent attorneys
September 12, 2007



I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on September 12, 2007.

Laura J. Pleasants
Date of Signature

September 12, 2007

RICHARD E. JENKINS

JEFFREY L. WILSON

ARLES A. TAYLOR, JR.

GREGORY A. HUNT

BENTLEY J. OLIVE

*CHRIS PERKINS, PH.D.

DAVID M. SIGMON

WESLEY A. SHEFFIELD

SCOTT C. MAYHEW

+KIRBY A. TURNER

BENJAMIN J. AIKEN

- PATENT AGENTS
JAY KLINCK
AMY ODENBAUGH, PH.D.
LAURA L. KIEFER, PH.D.

TECHNICAL SPECIALIST
LEON R. LEGLEITER, PH.D.

.....
*LICENSED ONLY IN CA
+LICENSED ONLY IN GA

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: U.S. Patent Application Serial No. 10/615,842 for
DEPOSITION METHOD FOR NANOSTRUCTURE
MATERIALS
Our Ref. No. 421/170/8/2 CIP

Sir:

Please find enclosed in connection with the subject U.S. patent application the following documents:

1. Supplemental Information Disclosure Statement (2 pages);
2. Form PTO-1449 (1 pages);
3. Copies of cited references (2 references);
4. A return-receipt postcard to be returned to us with the U.S. Patent and Trademark Office filing stamp thereon; and

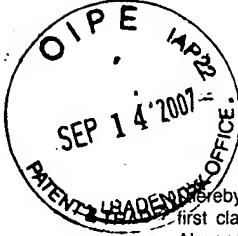
Please contact our offices if there are any questions with this matter.

Respectfully submitted,

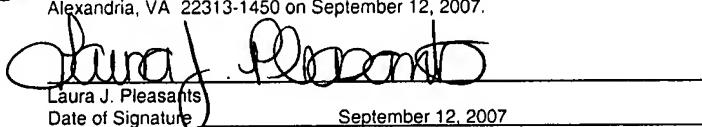
JENKINS, WILSON, TAYLOR & HUNT, P.A.

Jeffrey L. Wilson
Registration No. 36,058
Customer No: 25297

Enclosures



I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on September 12, 2007.


Laura J. Plessants

Date of Signature

September 12, 2007

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Oh et al.

Group Art Unit: 1753

Serial No.: 10/615,842

Examiner: Phasge, Arun S.

Filed: July 10, 2003

Docket No.: 421/170/8/2 CIP

Confirmation No.: 9995

For: DEPOSITION METHOD FOR NANOSTRUCTURE MATERIALS

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. 1.56, 1.97, and 1.98, applicants' undersigned attorney brings to the attention of the Patent and Trademark Office the documents listed on the attached Form PTO-1449. Copies of the references as well as Form PTO-1449 are attached hereto. This is not to be construed as a representation that a search has been made or that a reference is relevant merely because cited.

No fee under 37 C.F.R. Section 1.17(p) is due as the undersigned hereby certifies that each item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Serial No.: 10/615,842

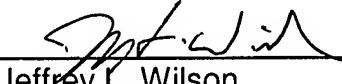
Early passage of the subject application to issue is earnestly solicited.

Although it is believed that no fee is due, the Commissioner is hereby authorized to charge any fees associated with the filing of this Information Disclosure Statement to Deposit Account No. **50-0426**.

Respectfully submitted,

JENKINS, WILSON, TAYLOR & HUNT, P.A.

Date: September 12, 2007

By: 

Jeffrey L. Wilson
Registration No. 36,058
Customer No: 25297

Enclosures



FORM PTAB 1449 U.S. Department of Commerce
Patent and Trademark Office

List of Documents Cited by Applicant

Application No.:	10/615,842
Filing Date:	July 10, 2003
First Named Inventor:	Oh
Group:	1753
Examiner:	Phasge, Arun S.
Attorney Docket No.:	421/170/8/2 CIP

U.S. PATENT DOCUMENTS

Examiner Initial	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where relevant passages or relevant figures appear
	1.	7,252,749	8/07/2007	Zhou et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number (country code, no., kind code (if known))	Publication Date	Name of Patentee or Applicant	Pages, columns, lines where relevant passages appear	T

OTHER DOCUMENTS

Examiner Initials	Cite No.	Include Author (in CAPITAL LETTERS), Title, Journal, Date, Pertinent Pages, Etc.	T
	1.	Korean Intellectual Property Office (KIPO) Office Action for Korean Patent Application No. 10-2006-7000476 dated June 19, 2007	

EXAMINER _____ DATE CONSIDERED _____

*Examiner Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.